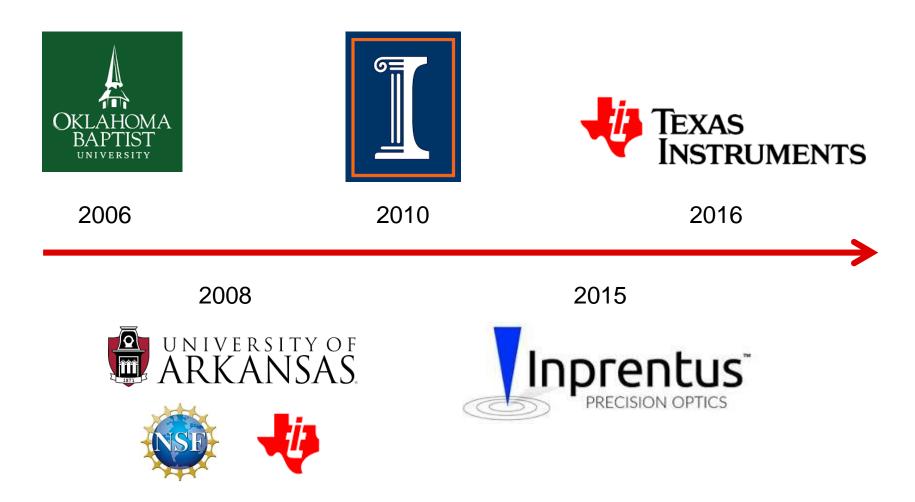
A Physicist's First Year in Industry

Taylor Byrum 2/27/2017



My path to Texas Instruments



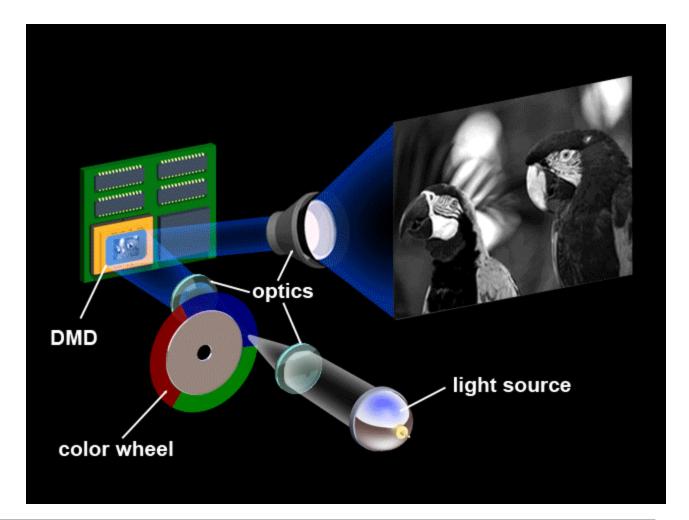
http://physics.illinois.edu/careers-seminar/UIUC_Physics_Career_Seminar_Byrum.pdf



DLP[®] Technology

Digital Micromirror Device (DMD)



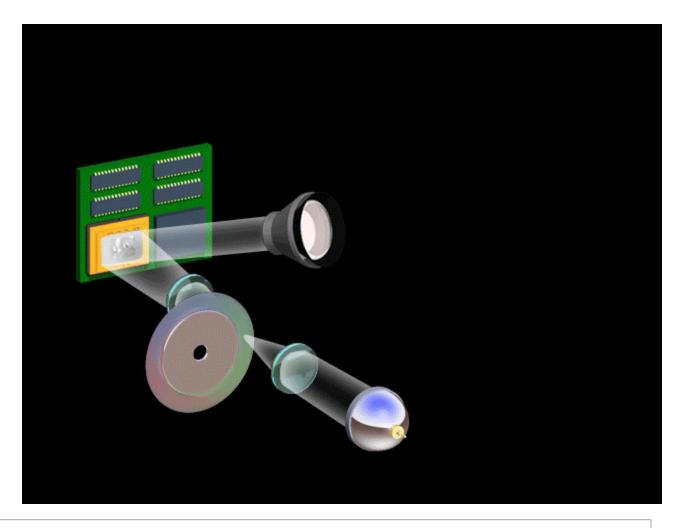




DLP Technology

Digital Micromirror Device (DMD)





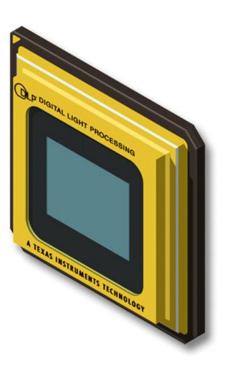


Digital Micromirror Device (DMD)

MEMS device Invented by solid state physicist Larry Hornbeck

Number of mirrors 150,000 to >4,000,000

Mechanical elements Aluminum



Mechanical motion

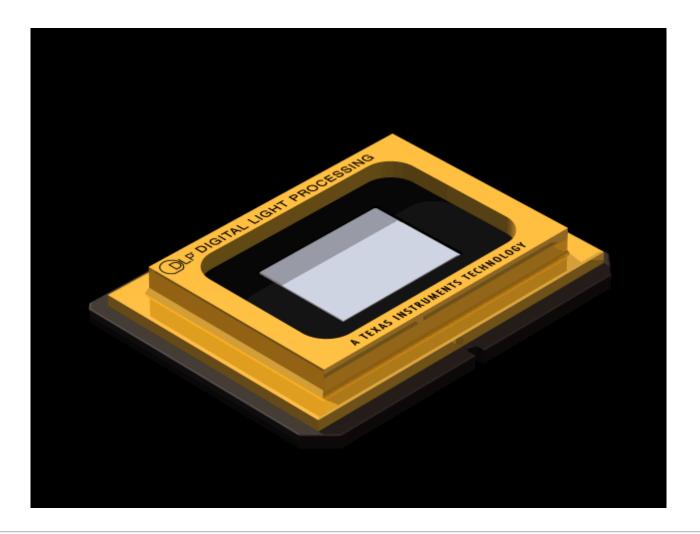
Makes discrete contacts or landings

Address voltage 3.3-volt CMOS technology

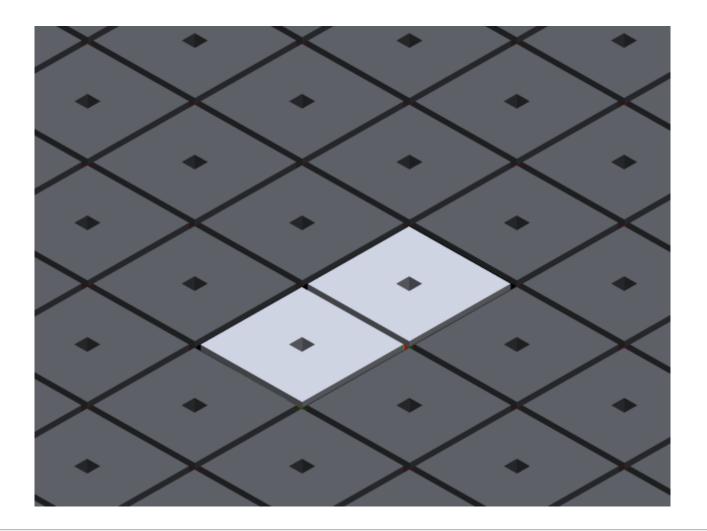
> **Lifetime** up to 100,000 hrs

Process Low temperature, sputter deposition, plasma etch (standard SC processes)

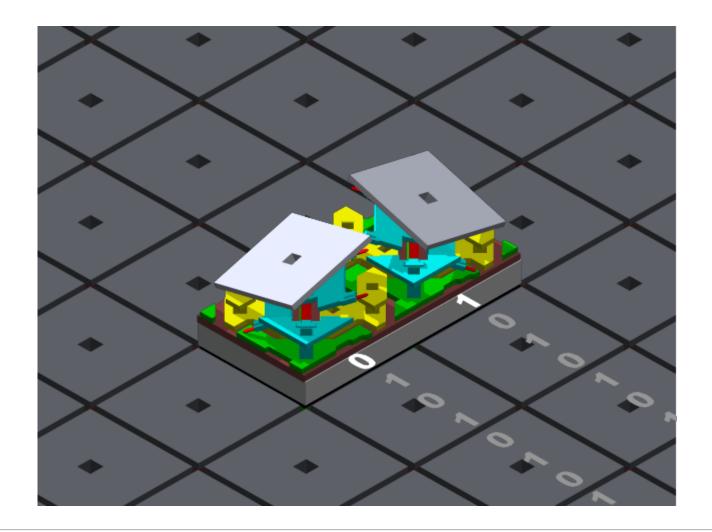




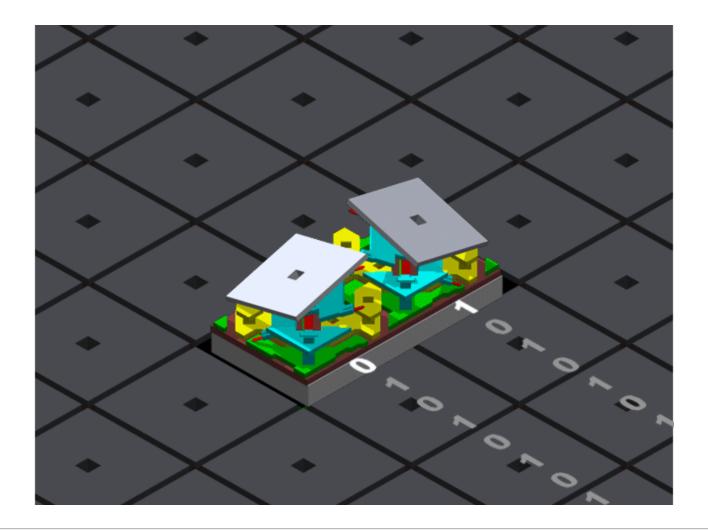




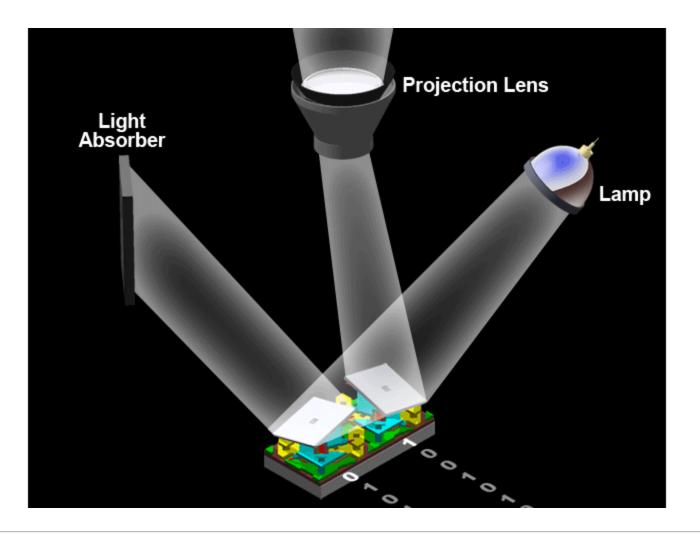




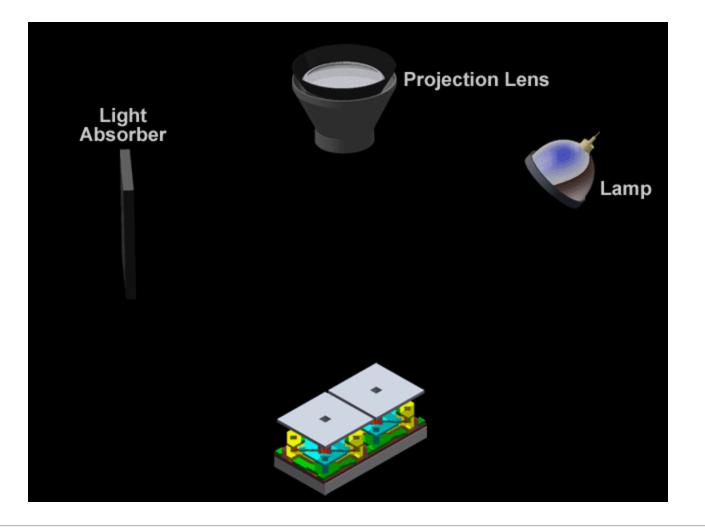




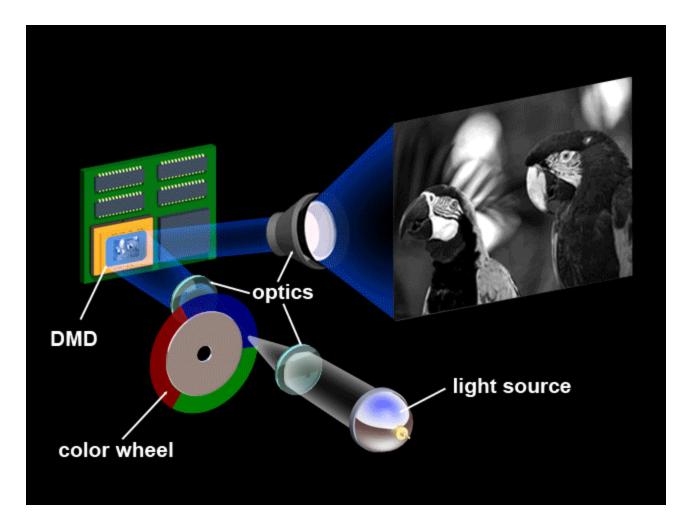








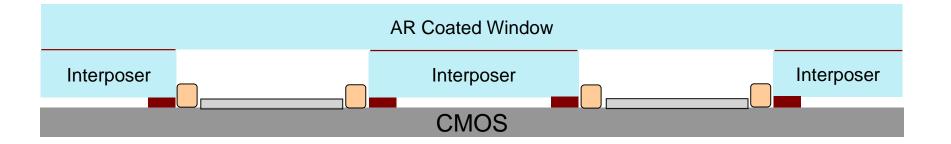






What I work on

- Process development engineer
 - Stiction (static friction)
- Projects
 - "Fundamental understanding" of headspace
 - Wafer-level packaging
 - New applications





Benefits of Physics PhD – Example

- Problem: Ongoing moisture permeation problem with specific device.
 Abnormally large distribution of moisture in package.
- Hypothesis: Poor UV curing of epoxy at bondlines, resulting in excessive moisture permeation.
 - No clear reason why these devices had uncured epoxy while epoxy in other devices was cured.
- While working on another project, I noticed peculiarities in the interferometric measurements on these devices.
 - These peculiarities had been observed by others but had been disregarded.

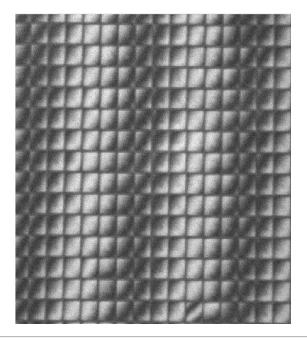
The following slides are from a presentation I gave shortly after I started this job.

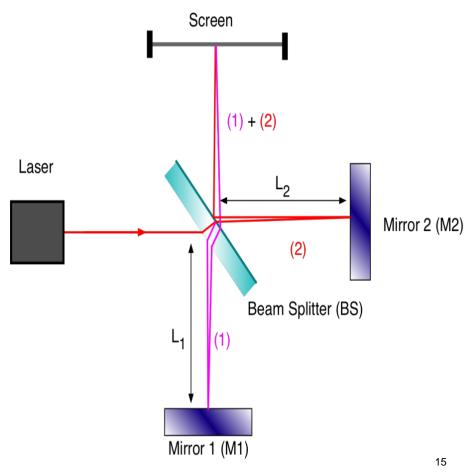


Interferometry peculiarities observed

Observation #1: All dies from a single wafer showed very similar modulation % values of either 30-40% or 10-20%.

Observation #2: Modulation % values changed between some wafers.







Modulation %

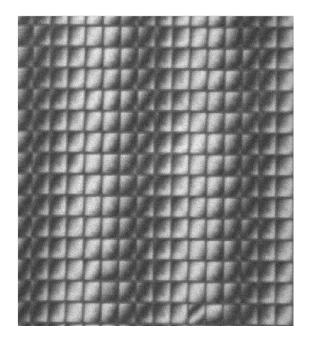
Modulation % is like a contrast ratio of the fringes.

- 10-20% is "bad", data is swamped by noise.
- 30-40% is "good", data quality looks good.

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Modulation 14%

Modulation 40%



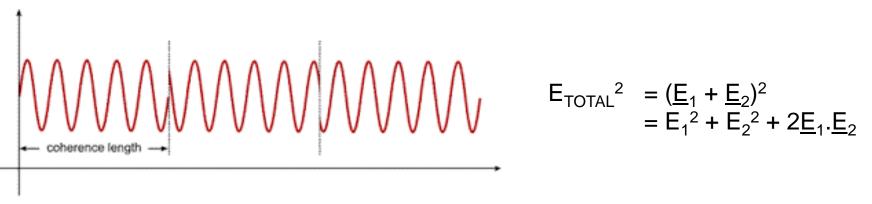


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Understanding modulation %

Interferometry Basics

- Interference pattern (fringes) requires coherence length to be greater than optical path length difference between splits beams.
 - Optical path length (OPL) = (index of refraction of medium)*(length of travel)
 - In this case, light source is blue LED and has CL = 4.7 microns.
- Ideally, the split beams should have the same intensity when they recombine.
 - Modulation % is maximized for equally intense beams.





What could cause modulation % variations?

OPL Differences

- Window thickness
- Index of refraction

Relative Beam Intensities

- Transmissions due to AR coating differences
- Window thickness
- Reflectivity of the mirror array*

Further experiments showed that windows from supplier had two distinct flavors, which had subtle differences in both window thickness and AR coating transmission properties.

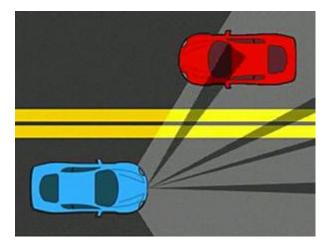
- Window thickness differences likely accounted for what I observed.
- Transmission properties accounted for poor UV curing of epoxy.

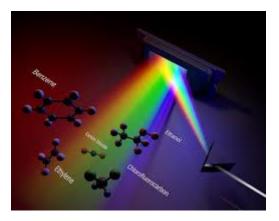
*Ruled out by experiment where I swapped the windows

What I like about my job

- Interdisciplinary
- Team environment
 - Work alongside some other PhDs from different fields, but mainly surrounded by BSs in mechanical and electrical engineering
- Mature technology, but impacts can still be made
- Work stays at work
- Cool technology with interesting applications still to come







https://www.youtube.com/watch?v=-8L7iKaW25o



Final words

- My advice for getting a job in industry:
 - Make a contact with someone in the company (networking)
 - Show interest/passion for the position or technology
- If you're worried about early job performance like I was:
 - You'll learn the job on the job
 - They hired you knowing you currently are not an expert
- Feel free to connect with me on LinkedIn or e-mail me at t-byrum@ti.com

Thank you!

